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GERALD T. SHEKLETON	(Depositor's name)
<i>Gerald T. Shekleton</i>	(Signature)
April 23, 2007	(Date)

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/512,022	10/19/2004	Tetsuhiro Iida	93120	2202

TITLE OF INVENTION: SINGLE CRYSTAL SILICON PRODUCING METHOD, SINGLE CRYSTAL SILICON WAFER PRODUCING METHOD, SEED CRYSTAL FOR PRODUCING SINGLE CRYSTAL SILICON, SINGLE CRYSTAL SILICON INGOT, AND SINGLE CRYSTAL SILICON WAFER

APPLN. TYPE	SMALL ENTITY	ISSUE FEE DUE	PUBLICATION FEE DUE	PREV. PAID ISSUE FEE	TOTAL FEE(S) DUE	DATE DUE
nonprovisional	NO	\$1400	\$300	\$0	\$1700	05/07/2007

EXAMINER	ART UNIT	CLASS-SUBCLASS
HITESHEW, FELISA CARLA	1722	117-013000

1. Change of correspondence address or indication of "Fee Address" (37 CFR 1.363).

- ☐ Change of correspondence address (or Change of Correspondence Address form PTO/SB/122) attached.
☐ "Fee Address" indication (or "Fee Address" Indication form PTO/SB/47; Rev 03-02 or more recent) attached. Use of a Customer Number is required.

2. For printing on the patent front page, list

- (1) the names of up to 3 registered patent attorneys or agents OR, alternatively,
 (2) the name of a single firm (having as a member a registered attorney or agent) and the names of up to 2 registered patent attorneys or agents. If no name is listed, no name will be printed.

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3. ASSIGNEE NAME AND RESIDENCE DATA TO BE PRINTED ON THE PATENT (print or type)

PLEASE NOTE: Unless an assignee is identified below, no assignee data will appear on the patent. If an assignee is identified below, the document has been filed for recordation as set forth in 37 CFR 3.11. Completion of this form is NOT a substitute for filing an assignment.

(A) NAME OF ASSIGNEE

(B) RESIDENCE: (CITY and STATE OR COUNTRY)

SUMCO TECHXIV CORPORATION

HIRATSUKA-SHI, KANAGAWA, JAPAN

Please check the appropriate assignee category or categories (will not be printed on the patent): ☐ Individual ☒ Corporation or other private group entity ☐ Government

4a. The following fee(s) are submitted:

- ☒ Issue Fee
☒ Publication Fee (No small entity discount permitted)
☐ Advance Order - # of Copies

4b. Payment of Fee(s): (Please first reapply any previously paid issue fee shown above)

- ☒ A check is enclosed.
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☒ The Director is hereby authorized to charge the required fee(s), any deficiency, or credit any overpayment, to Deposit Account Number 23-0920 (enclose an extra copy of this form).

5. Change in Entity Status (from status indicated above)

- ☐ a. Applicant claims SMALL ENTITY status. See 37 CFR 1.27. ☐ b. Applicant is no longer claiming SMALL ENTITY status. See 37 CFR 1.27(g)(2).

NOTE: The Issue Fee and Publication Fee (if required) will not be accepted from anyone other than the applicant; a registered attorney or agent; or the assignee or other party in interest as shown by the records of the United States Patent and Trademark Office.

Authorized Signature

Gerald T. Shekleton

Date

4/23/07

Typed or printed name

GERALD T. SHEKLETON

Registration No.

27,466

This collection of information is required by 37 CFR 1.311. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, Virginia 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.

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93120



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application)
)
Applicant: Iida et al.)
) Confirmation No. 2202
Serial No.: 10/512,022)
)
Filed: October 19, 2004)
)
For: Method for Producing Single Crystal)
Silicon, Method for Producing Single)
Crystal Silicon Wafer, Seed Crystal for)
Producing Single Crystal Silicon, Single)
Crystal Silicon Ingot, and Single Crystal)
Silicon Wafer)
)
Examiner: Felisa Carla Hiteshew)
)
Art Unit: 1722)

ISSUE FEE TRANSMITTAL LETTER

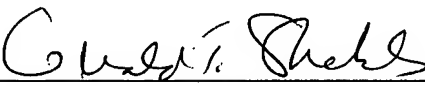
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Sir:

Attached is the Issue Fee Transmittal Form No. PTOL-85B, in duplicate, our
Check No. 104885 in the amount of \$1,700.00 for the Issue Fee relating to the issuance of the
above-identified U.S. patent application under 37 C.F.R. §1.18, and publication.

The Commissioner is authorized to charge payment of any deficiency in the patent issue fee or credit any overpayment to Deposit Account No. 23-0920. A duplicate copy of this transmittal letter is enclosed.

Respectfully submitted,


By 
Gerald T. Shekleton, Reg. No. 27,466

Date: April 23, 2007

WELSH & KATZ, LTD.
120 South Riverside Plaza, 22nd Floor
Chicago, Illinois 60606
Phone (312) 655-1500
Facsimile Number (312) 655-1501

CERTIFICATE OF MAILING
OF ISSUE FEE TRANSMITTAL

I hereby certify that this Issue Fee Transmittal Letter, in duplicate, the attached Issue Fee Transmittal Form PTOL-85B, in duplicate, and the attached Issue Fee check relating to the above-identified U.S. patent application, are enclosed together in an envelope being deposited with the United States Postal Service with sufficient postage as First Class Mail addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 23, 2007.


Gerald T. Shekleton, Reg. No. 27,466